

**S/N 10/788,899**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	Kevin Torek et al.	Examiner:	Anita Alanko
Serial No.:	10/788,899	Group Art Unit:	1792
Filed:	February 27, 2004	Docket No.:	303.866US1
Customer No.:	73115	Confirmation No.:	4587
Title:	METHOD OF FORMING HIGH ASPECT RATIO STRUCTURES		

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**COMMUNICATION RE: FEE ADDRESS**

Mail Stop Issue Fee  
Commissioner for Patents  
P.O.Box 1450  
Alexandria, VA 22313-1450

In response to the Notice of Allowance and Issue Fee Due, please record the Fee Address under the provisions of 37 CFR 1.363 as the following:

**Customer Number 26809**

which is associated with Micron Technology, Inc..

Please direct any inquiries to the undersigned attorney at (612) 349-9587.

Respectfully submitted,

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Date 18 Nov. '08

By 

Timothy B. Clise  
Reg. No. 40,957

TBC:CMG:kerl

**CERTIFICATE UNDER 37 CFR 1.8:** The undersigned hereby certifies that this correspondence is filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 18 day of November, 2008.

KATHLEEN E. ROTHRAK  
Name

Kathleen E Rothrak  
Signature